

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10595686			
<b>Filing Date:</b>	27-Dec-2006			
<b>Title of Invention:</b>	Method for Forming ZnO Nano-Array and ZnO Nanowall for Uv Laser On Silicon Substrate			
<b>First Named Inventor/Applicant Name:</b>	Jin Ho Choy			
<b>Filer:</b>	Joseph A. Hynds/wendy carballo			
<b>Attorney Docket Number:</b>	1751-405			
Filed as Small Entity				
<b>U.S. National Stage under 35 USC 371 Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
<b>Extension-of-Time:</b>				
Extension - 1 month with \$0 paid	2251	1	65	65

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
Request for continued examination	2801	1	405	405
<b>Total in USD (\$)</b>				<b>470</b>